

Notice of References Cited	Application/Control No. 10/696,545		Applicant(s)/Patent Under Reexamination DENG, XUNMING	
	Examiner Jeffrey T. Barton		Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ma, W et al, "The Utilization of Microcrystalline Si and SiC for the Efficiency Improvement in a-Si Solar Cells", Conf. Rec. of the 24th IEEE Photovoltaic Specialists Conference. vol 1, p 417-420. (1994)
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	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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